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2771-510

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:) Confirmation No.:	1232
Applicant:	Baum, Thomas H., et al.) Docket No.:	2771-510
Application No.:	09/823,196) Examiner:	Colleen E. Rodgers
Date Filed:	March 30, 2001) Group Art Unit:	2813
Title:	SOURCE REAGENT COMPOSITIONS FOR CVD FORMATION OF GATE DIELECTRIC THIN FILMS USING AMIDE PRECUSORS AND METHOD OF USING SAME	Customer No.:))))))	25559

FACSIMILE TRANSMISSION CERTIFICATE Mail Stop ISSUE FEE Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Issue Fee, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on November 11, 2005 to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

10 Number of Pages Tristan A. Fuierer November 11, 2005 Date

SUBMISSION OF AMENDMENT UNDER 37 CFR 1.312 IN UNITED STATES PATENT **APPLICATION NO. 09/823,196**

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

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In response to the August 25, 2005 Notice of Allowance in the above-identified application, please amend the application under the provisions of 37 CFR 1.312 as set out in the following Section I (Amendments to the Claims).

Remarks are set out in the Section II (Remarks) hereof.